AKIMA-DTSV 23 MAY 2005

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Application Number	See attached schedule	
Filing Date		
First Named Inventor		
Art Unit		
Examiner Name		
Attorney Docket Number		

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Applicant/Inventor							
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Registered practitioner named in the application transmittal letter in an application without an executed oath or declaration. See 37 CFR 1.33(a)(1). Registration Number							
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Typed or Printed Tamsen Valoir, Ph.D.				4.50			
Date 4./3.2005			3.427.5007				
NOTE: Signatures of all the inventors or assignees of rec forms if more than one signature is required, see below*.	ord of the entire interest or the	ir representative(s)	are required. Submit multiple				
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SCHEDULE A - PATENTS AND PATENT APPLICATIONS (S T M icroelectronics)	ENTS AND PATENT T M icroelectronics)	·				•
Docket No.	Title of Invention	Appl. No.	File Date	Patent No.	Issue Date	Reel/Frame No.
31175803-003001	Method and Device for Confining Live Neural Cells Cultivated on a Chip of Noninvasive Neuroelectronic Interfacing	11/040080	1/21/2005			n/a
31175803-004002	Apparatus for Biochemical Analysis	11/092415	3/29/2005			n/a
31175803-004001	Integrated Device for Biological Analyses	10/663286	9/16/2003			015030/0589
31175803-005001	Micropump for Integrated Device for Biological Analyses	10/663239	9/16/2003			014978/0331
31175803-006001	Integrated Device for Microfluid Thermoregulation, and Manufacturing Process Thereof	08/77/8080	2/8/2001	6673593	1/6/2004	011766/0716
31175803-006002	Integrated Device for Amplification and Other Biological Tests, and Manufacturing Process Thereof	10/706246	11/12/2003			011766/0716
31175803-007001	Process for Manufacturing Integrated Chemical Microreactors of Semiconductor Material	09/874382	6/4/2001	6710311	3/23/2004	014105/0698

014105/0698	014813/0881 014485/0695	014813/0881 014485/0695	012566/0773	012566/0773	012566/0773	n/a
	4/27/2004				8/3/2004	
	6727479				6770471	
2/23/2004	4/22/2002	3/8/2004	6/23/2004	6/23/2004	9/26/2001	11/24/2004
10/784509	10/128989	10/795589	10/874902	10/874905	09/965128	10/996593
Process for Manufacturing Integrated Chemical Microreactors of Semiconductor Material	Integrated Device Based Upon Semiconductor Technology, in Particular Chemical Microreactor	Integrated Device Based Upon Semiconductor Technology, in Particular Chemical Microreactor	Integrated Chemical Microreactor, Thermally Insulated from Detection Electrodes, and Manufacturing and Operating Methods Therefor	Integrated Chemical Microreactor, Thermally Insulated from Detection Electrodes, and Manufacturing and Operating Methods Therefor	Integrated Chemical Microreactor, Thermally Insulated from Detection Electrodes, and Manufacturing and Operating Methods Therefor	Integrated Chemical Microreactor with Large Area Channels and Manufacturing Process Thereof
31175803-007002	31175803-008001	31175803-008002	31175803-009002	31175803-009003	31175803-009001	31175803-011001

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pending	pending		pending	
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11/24/2004	12/10/2004	12/20/2004	12/17/2004	
10/997235	11/009171	11/017272	11/015633	
Integrated Chemical Microreactor with Separated Channels for Confining Liquids Inside the Channels and Manufacturing Process Thereof	Integrated Semiconductor Microreactor for Real- Time Monitoring of Biological Reactions	Microfluidic Device and Method for Transporting Electrically Charged Substances Through a Microchannel of a Microfluidic Device	Microfluidic Device and Method of Locally Concentrating Electrically Charged Substances in a Microfluidic Device	
31175803-012001		31175803-014001	31175803-015001	